



00862.022438.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yoshinori MIWA

Application No.: 09/987,568

Filed: November 15, 2001

For: EXPOSURE APPARATUS AND EXPOSURE
METHOD

)
: Examiner: H. Nguyen
)
: Group Art Unit: 2851
)
:
)
:
) September 8, 2003
: (Monday)

Mail Stop RCE

The Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to further examination on the merits, please amend the above-identified
application as follows:

09/10/2003 RHEBRAHT 00000034 09987568

02 FC:1251

110.00 OP